Electronic Supplementary Information for

Highly Flexible and Transparent Metal Grids Made of Metal Nanowire Networks

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Fig. S1 Surface morphologies of AgNW films with different pressing force. AFM images of AgNW films pressed at (a) 0 N, (b) 10 kN, (c) 30 kN, (d) 50 kN, and (e) 70 kN. (f) Average roughness (Ra) value as a function of pressing force.



Fig. S2 Transmittance spectra (400 nm to 800 nm) of AgNW MGs with different grid-to-grid pitch (wp) ranging from 100 μ m to 600 μ m and a step of 100 μ m.



Fig. S3 The optoelectronic performance of AgNW MGs processed with different chemical etching times of 0 sec to 24 sec with a step of 3 sec with and without PEDOT:PSS over-coating. (a) Sheet resistances and (b) transmittances at 550-nm wavelength of each AgNW MG.



Fig. S4 Transmittance spectrum (400 nm to 800 nm) of spray-coated PEDOT:PSS layer.



Fig. S5 Transmittance spectra (400 nm to 800 nm) of AgNW MGs processed with different chemical etching time (18, 21, 24 sec) with and without PEDOT:PSS over-coating.



Fig. S6 SEM images of PEDOT:PSS-coated AgNW MG after repetitive bending tests for up to 500 cycles (scale bars: $10 \mu m$ (left), $2 \mu m$ (right).